



Attorney Docket No. 0756-7295

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Koichiro TANAKA

Serial No. 10/827,402

Filed: April 20, 2004

For: BEAM IRRADIATION APPARATUS,

BEAM IRRADIATION METHOD, AND

METHOD FOR MANUFACTURING

THIN FILM TRANSISTOR

) Group Art Unit: 2891

) Examiner: Bradley Smith

) CERTIFICATE OF MAILING

) I hereby certify that this correspondence is
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Adam S. Stamps

AMENDMENT

Honorable Commissioner of Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

In response to the Official Action dated February 29, 2008, please consider the following amendments and remarks in connection with the above-identified application.

Amendments to the Claims are reflected in the listing of claims, which begins on page 2 of this paper.

Remarks begin on page 8 of this paper.